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SERIAL NUMBER 10/600,332	FILING DATE 06/23/2003  RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. P68917US0	
<b>APPLICANTS</b>  Cheol Hwan Park, Seoul, KOREA, REPUBLIC OF;  Dong Su Park, Gyeonggi-do, KOREA, REPUBLIC OF; Tae Hyeok Lee, Gyeonggi-do, KOREA, REPUBLIC OF; Sang Ho Woo, Gyeonggi-do, KOREA, REPUBLIC OF;					
*** CONTINUING DATA ***** <i>none</i>					
** FOREIGN APPLICATIONS ***** <i>SR</i> REPUBLIC OF KOREA 2002-42462 07/19/2002					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/26/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>Allowance</i> Acknowledged <i>Handwritten Signature</i> <i>SR</i> Examiner's Signature Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 1
<b>ADDRESS</b> 00136 JACOBSON HOLMAN PLLC 400 SEVENTH STREET N.W. SUITE 600 WASHINGTON , DC 20004					
<b>TITLE</b> Method for forming device isolation film of semiconductor device					
			<input type="checkbox"/> All Fees		